



IFW 2825

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
MARKUS NOPPER
AXEL PREUSSE

Examiner: Caridad Everhart

Group Art Unit: 2825

Serial No.: 10/602,192

Att'y Docket: 2000.106500/DE0260


Filed: June 24, 2003

Customer No.: 23720

For: METHOD OF FORMING A METAL
LAYER OVER A PATTERNED
DIELECTRIC BY ELECTROLESS
DEPOSITION USING A CATALYST

RESPONSE TO OFFICE ACTION DATED OCTOBER 29, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
November 8, 2004 Date	 Signature

Sir:

This paper is submitted in response to the Office Action dated October 29, 2004, for which the three-month date for response is January 29, 2005.

A fee in the amount of \$582.00 is believed to be due in connection with the present paper. **The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0260.** In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.106500.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

11/12/2004 HVUONG1 00000160 010365 10602192

01 FC:1201 528.00 DA
02 FC:1202 54.00 DA